

Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/817,355
				Filing Date	April 1, 2004
				First Named Inventor	WOODS
				Art Unit	1765
Examiner Name	Unassigned				
Attorney Docket Number	LAM2P472				
Sheet	3	of	4		

## U.S. Patent Documents

Examiner Initials	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
/JLP/	A	5,893,004	04/06/99	Yamamura	
	B	6,086,454	07/11/00	Watanabe et al.	
	C	6,092,937	07/25/00	Snodgrass et al.	
	D	6,103,636	08/15/00	Zahorik et al.	
	E	6,108,932	08/29/00	Chai	
	F	6,230,722	05/15/01	Mitsumori et al.	
	G	6,417,117	07/09/02	Davis	
	H	6,488,040	12/03/02	De Larios et al.	
	I	6,495,005	12/17/02	Colgan et al.	
	J	6,530,823	03/11/03	<del>Goodarz et al.</del>	Ahmadi et al.
	K	6,550,988	04/22/03	Sugimoto et al.	
	L	6,555,017	04/29/03	Rushford et al.	

## Foreign Patent Documents

Examiner Initial	Cite No. <sup>1</sup>	Foreign Patent Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number-Kind Code <sup>4</sup> (if known)				
/JLP/	M	WO 99/49504	9/30/99	Nippon Kogaku KK		<input type="checkbox"/>
/JLP/	N	JP 62150828 A	07/04/87	Mitsubishi Electric Corporation		<input type="checkbox"/>

## Non Patent Literature Documents

Examiner Initial	Cite No.	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
/JLP/	O	SIGMA-ALDRICH, "Atomic Layer Deposition (ALD)", <a href="http://www.sigmaaldrich.com/Area_of_Interest/Chemistry/Materials_Science/Thin_Films">http://www.sigmaaldrich.com/Area_of_Interest/Chemistry/Materials_Science/Thin_Films</a> , 2005, Pages 1-2
	P	

Examiner Signature	/Joseph L. Perrin/	Date Considered	03/28/2007
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language translation is attached.